



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Patent Application of

Jon Opsal

Application No.: 10/696,269

Filed: October 29, 2003

For: DETECTOR CONFIGURATIONS FOR
OPTICAL METROLOGY

Confirmation No.: 6485

Group Art Unit: 2877

Examiner: Hoa Q. Pham

**RESPONSE TO OFFICE ACTION
MAILED MAY 6, 2004**353 Sacramento Street, Suite 2200
San Francisco, CA 94111
(415) 772-4900M/S AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on August 2, 2004.
STALLMAN & POLLOCK LLP

Dated: 08/2/2004 By:

Georgia L. Stith
Georgia L. Stith

Sir:

In response to the Office Action mailed May 6, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.